

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OZAKI, Takashi, et al.**

Group Art Unit: 1792

Serial No.: 10/528,137

Examiner: **MACARTHUR, Sylvia**

Filed: **December 12, 2005**

P.T.O. Confirmation No.: 2307

For. **SUBSTRATE PROCESSING APPARATUS AND METHOD FOR
MANUFACTURING A SEMICONDUCTOR DEVICE**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 9, 2010


Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Final Office Action dated November 13, 2009 for one month, from February 13, 2010 to March 13, 2010.

The Commissioner is authorized to charge our Deposit Account in the amount of \$130.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP


James N. Baker
Agent for Applicant
Reg. No. 40,899

JNB/ak

Atty. Docket No. **050161**
Suite 400
1420 K Street, N.W.
Washington, D.C. 20005
(202) 659-2930



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PATENT & TRADEMARK OFFICE